

Attorney's Docket No.: 042390P3955D

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of: )

Andideh, Ebrahim et al. )

U.S. Serial No: 09/436,092 )

Examiner: McDonald, Shantese L.

Filed: November 8, 1999 )

Art Unit: 3723

For: POLISH PAD WITH )  
NON-UNIFORM GROOVE DEPTH )  
TO IMPROVE WAFER POLISH RATE )  
UNIFORMITY )

Commissioner for Patents  
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Alexandria, VA 22313-1450

**FORMAL DRAWINGS SUBMISSION**

Enclosed herewith for submission in the United States Patent and Trademark Office  
are five (5) sheets of formal drawings for the patent application referenced above.

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Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Dated: March 17, 2005

  
\_\_\_\_\_  
George Chen  
Reg. No. 50,807

12400 Wilshire Boulevard  
Seventh Floor  
Los Angeles, California 90025-1026  
(408) 720-8300